

WEST[Help](#)[Logout](#)[Interrupt](#)[Main Menu](#)[Search Form](#)[Posting Counts](#)[Show S Numbers](#)[Edit S Numbers](#)[Preferences](#)**Search Results -**

Term	Documents
PT.DWPI,TDBD,EPAB,JPAB,USPT,PGPB.	729917
PTS.DWPI,TDBD,EPAB,JPAB,USPT,PGPB.	124967
PLATINUM.DWPI,TDBD,EPAB,JPAB,USPT,PGPB.	126335
PLATINUMS.DWPI,TDBD,EPAB,JPAB,USPT,PGPB.	34
(28 AND (PLATINUM OR PT)).USPT,PGPB,JPAB,EPAB,DWPI,TDBD.	22

Database:

US Patents Full-Text Database
 US Pre-Grant Publication Full-Text Database
 JPO Abstracts Database
 EPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Refine Search:

L28 and (Pt or platinum)

[Clear](#)**Search History****Today's Date: 6/27/2001**

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	L28 and (Pt or platinum)	22	L32
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	L28 and catalyst	3	L31
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	L28 and catalysis	0	L30
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	L28 and filament	0	L29
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	L27 and (CVD same ((cleaning gas) same ("NF.sub.3" or "F.sub.2" or fluorine or "Cl.sub.2" or chlorine or "CF.sub.4" or "C.sub.2F.sub.6" or	103	L28

	"C.sub.3F.sub.8" or "CCl.sub.4" or "ClF.sub.3" or "SF.sub.6"))		
	CVD and ((cleaning gas) same ("NF.sub.3" or "F.sub.2" or fluorine or "Cl.sub.2" or chlorine or "CF.sub.4" or "C.sub.2F.sub.6" or "C.sub.3F.sub.8" or "CCl.sub.4" or "ClF.sub.3" or "SF.sub.6"))	269	<u>L27</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	L25 and (cleaning near2 (gas or vapor))	12	<u>L26</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	((filament or element or wire) near2 (\$2CVD or (vapor deposition)))	1490	<u>L25</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	((filament or element or wire) near4 (\$2CVD or (vapor deposition)))	3138	<u>L24</u>
JPAB,EPAB,DWPI,TDBD	(thermal (catalyst or catalysis) (body or filament or element or wire))	1	<u>L23</u>
USPT,PGPB	(thermal (catalyst or catalysis) (body or filament or element or wire))	1	<u>L22</u>
JPAB,EPAB,DWPI,TDBD	08257675	2	<u>L21</u>
JPAB,EPAB,DWPI,TDBD	257675	7	<u>L20</u>
USPT,PGPB	L18 and cleaning	0	<u>L19</u>
USPT,PGPB	5149375.pn.	1	<u>L18</u>
USPT,PGPB	5478609.pn.	1	<u>L17</u>
JPAB,EPAB,DWPI,TDBD	((Pt or platinum) near5 (wire or filament)) and (\$2CVD or (vapor deposition))	33	<u>L16</u>
USPT,PGPB	((Pt or platinum) near5 (wire or filament)) same (\$2CVD or (vapor deposition))	28	<u>L15</u>
USPT,PGPB	5091209.pn.	1	<u>L14</u>
USPT,PGPB	6069094.pn.	1	<u>L13</u>
JPAB,EPAB,DWPI,TDBD	(hot near2 (element or wire or filament) near2 (\$2CVD or (vapor deposition))) and (platinum or Pt)	7	<u>L12</u>
USPT,PGPB	(hot near2 (element or wire or filament) near2 (\$2CVD or (vapor deposition))) same (platinum or Pt)	8	<u>L11</u>
USPT,PGPB	CCVD or (catalyst adj (CVD or (vapor deposition)))	41	<u>L10</u>
USPT,PGPB	CCVD or (catalyst near2 (CVD or vapor))	2640	<u>L9</u>
JPAB,EPAB,DWPI,TDBD	CCVD	11	<u>L8</u>
JPAB,EPAB,DWPI,TDBD	((catalytic or catalyst) near3 (\$2CVD or (vapor deposition)))	91	<u>L7</u>

USPT,PGPB	(catalytic near3 (\$2CVD or (vapor deposition)))	48	<u>L6</u>
JPAB,EPAB,DWPI,TDBD	L4 and clean\$3	2	<u>L5</u>
JPAB,EPAB,DWPI,TDBD	(hot near2 (element or wire or filament) near2 (\$2CVD or (vapor deposition)))	97	<u>L4</u>
USPT,PGPB	L2 and (cleaning near2 (gas or vapor))	2	<u>L3</u>
USPT,PGPB	(hot near2 (element or wire or filament) near2 (\$2CVD or (vapor deposition)))	243	<u>L2</u>
USPT,PGPB	(hot near2 (element or wire or filament) near2 (\$2CVD or (vapor deposition))) and (Pt or platinum) and (cleaning near2 (gas or vapor))	0	<u>L1</u>